



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1763

PATENT APPLICATION  
Docket No. 5484-087  
Client No. PX1293-US/SSM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yong-Kil Kim                      Conf. No.      2611  
Serial No.                      10/072,443                      Examiner:      Zervigon, Rudy  
Filed:                      February 5, 2002                      Art Unit:      1763  
For:                      GAS DISTRIBUTION APPARATUS OF SEMICONDUCTOR  
EQUIPMENT

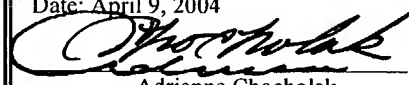
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**RESPONSE AFTER FINAL REJECTION UNDER 37 CFR 1.116**

This paper is responsive to the Final Office Action mailed 17 February 2004.  
A **Listing of Claims** is presented for the Examiner's convenience and begins on page 2 of this paper.  
**Remarks/Arguments** begin on page 4 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop AF Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450  
Date: April 9, 2004  
  
Adrienne Chocholak